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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

DN 51343

In re application of:

Seita et al.

Serial No.: 10/027,919

Filed: December 20, 2001

For: ELECTROLYTIC COPPER PLATING

SOLUTION AND METHOD FOR CONTROLLING THE SAME

: Group Art Unit: 1753

: Examiner: Edna Wong

<u>AMENDMENT</u>

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

In response to the Official Action mailed on October 21, 2003, Applicants submit the following amendments and remarks.

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.